Helen O. Chu	1795 Page	1 of 1	
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Notice of References Cited	KIMURA ET AL.		
Application/Control N	No. Applicant(s)/Patent Under Reexamination	Applicant(s)/Patent Under	

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2001/0004501	06-2001	Yi et al.	429/34
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